

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

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Title of Invention	CAPACITOR AND FABRICATION METHOD USING ULTRA-HIGH VACUUM CVD OF SILICON NITRIDE
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Application Number :

Confirmation Number:

First Named Applicant: John Bruley

Attorney Docket Number: FIS920030230US1

Art Unit:

Examiner:

Search string: (5943560 or 5540785 or 5462883).pn

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	5943560	1999-08-24	Chang, et al.			
	2	5540785	1996-07-30	Dennard, et al.			
	3	5462883	1995-10-31	Dennard, et al.			

Signature

Examiner Name	Date